

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

ROBERTUS D.J. VERHAAR ET AL

NL 000627

Serial No.

Group Art Unit

Filed: CONCURRENTLY

Ex.

Title: METHOD OF FORMING A SEMICONDUCTOR STRUCTURE

Commissioner for Patents
Washington, D.C. 20231

11002 U.S. PTO
09/989250
11/20/01



AUTHORIZATION PURSUANT TO 37 CFR §1.136(a)(3)
AND TO CHARGE DEPOSIT ACCOUNT

Sir:

The Commissioner is hereby requested and authorized to treat any concurrent or future reply in this application requiring a petition for extension of time for its timely submission, as incorporating a petition for extension of time for the appropriate length of time.

Please charge any additional fees which may now or in the future be required in this application, including extension of time fees, but excluding the issue fee unless explicitly requested to do so, and credit any overpayment, to Deposit Account No. 14-1270.

Respectfully submitted,

By _____
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